



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 19, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG660479658

LABORATORY GROWN DIAMOND

CUSHION BRILLIANT

6.94 X 5.53 X 3.69 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.07 CARAT

D

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

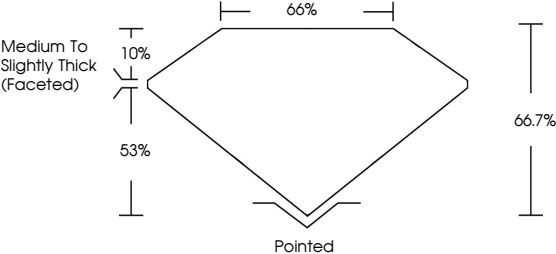
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG660479658

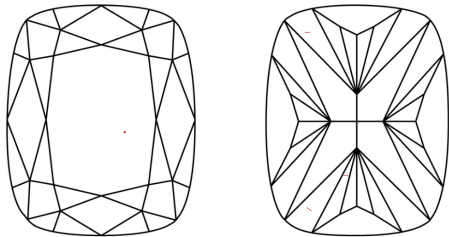
Report verification at igi.org

PROPORTIONS



Medium To Slightly Thick (Faceted)

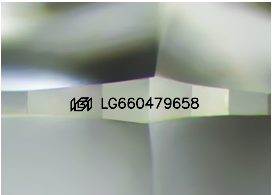
CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J

Faint Very Light Light

CLARITY

IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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IGI

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CUSHION BRILLIANT

6.94 X 5.53 X 3.69 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium to Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.07 CARAT

D

VS 1

66.7%

65%

Medium to Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

 LG660479658

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